

FIG. 1 RELATED ART

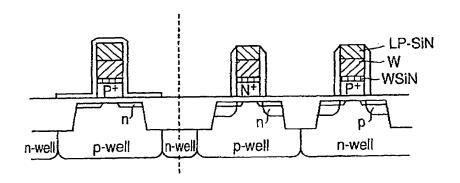


FIG. 2 RELATED ART

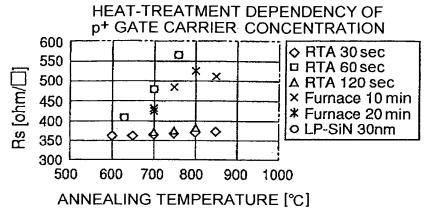


FIG. 3

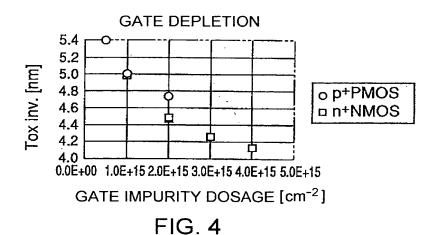


FIG. 5

IMPURITY CONCENTRATION DEPENDENCY OF W/polySi CONTACT RESISTANCE

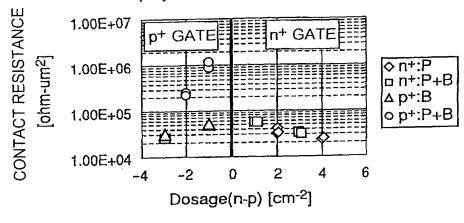


FIG. 6

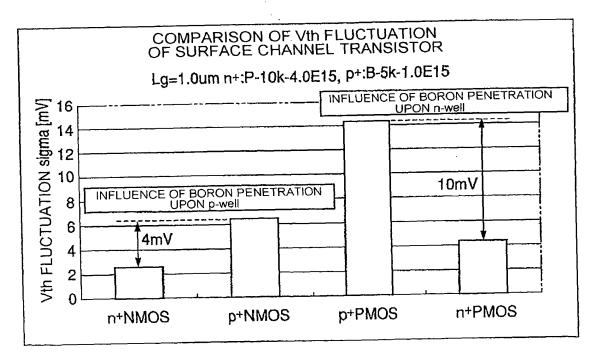


FIG. 7

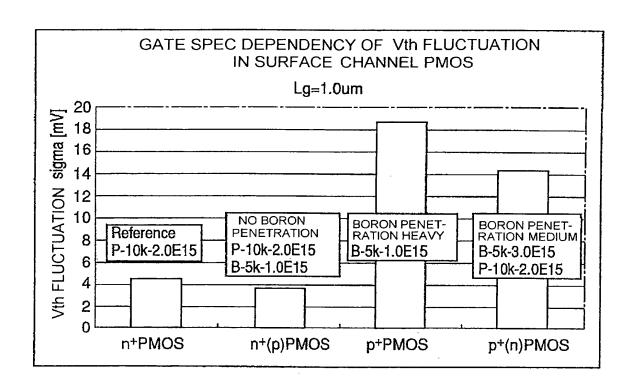


FIG. 8

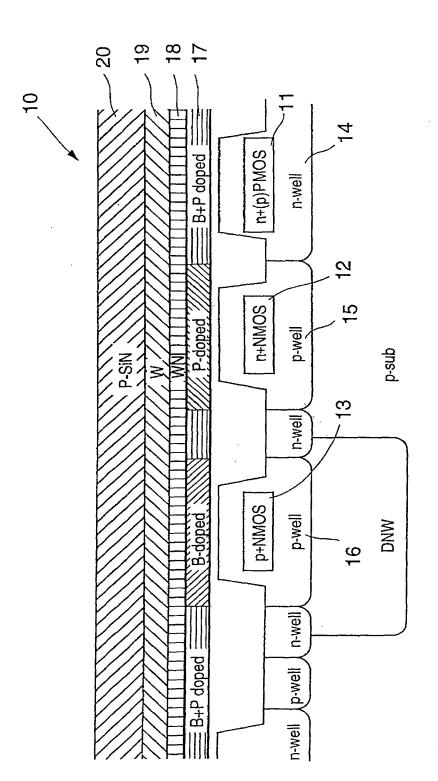


FIG. 9

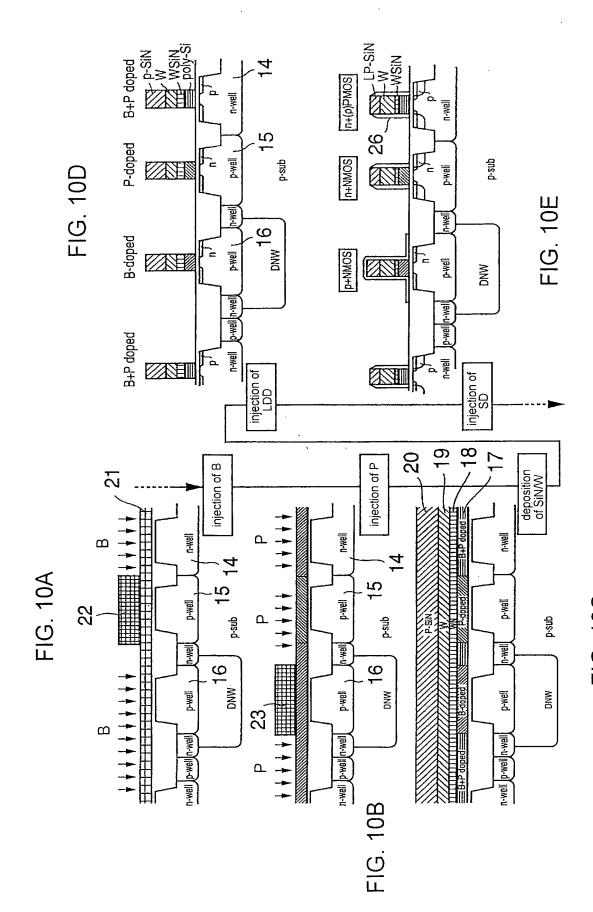


FIG. 10C

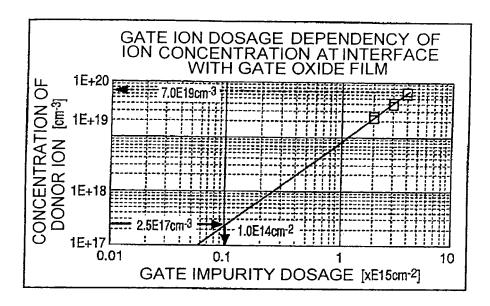


FIG. 11A

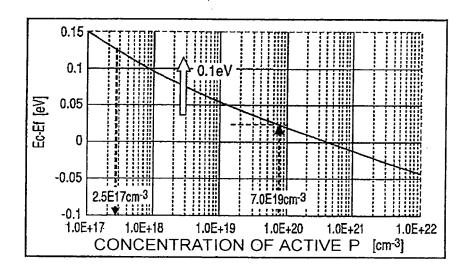
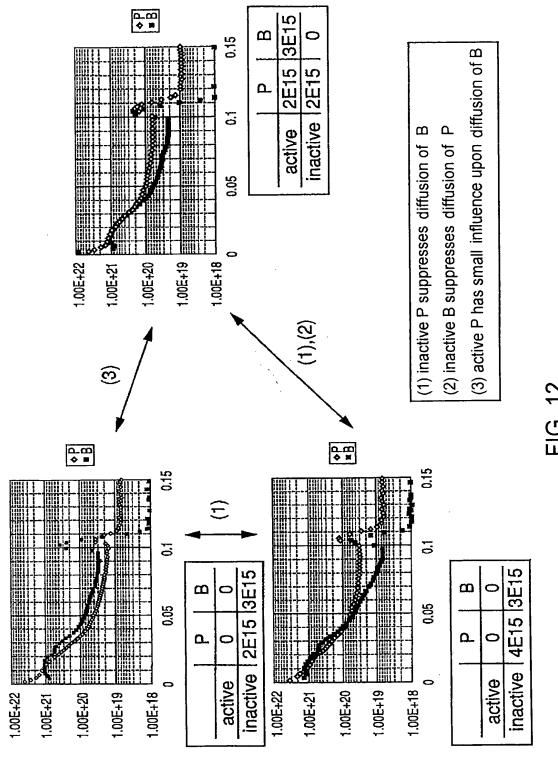


FIG. 11B



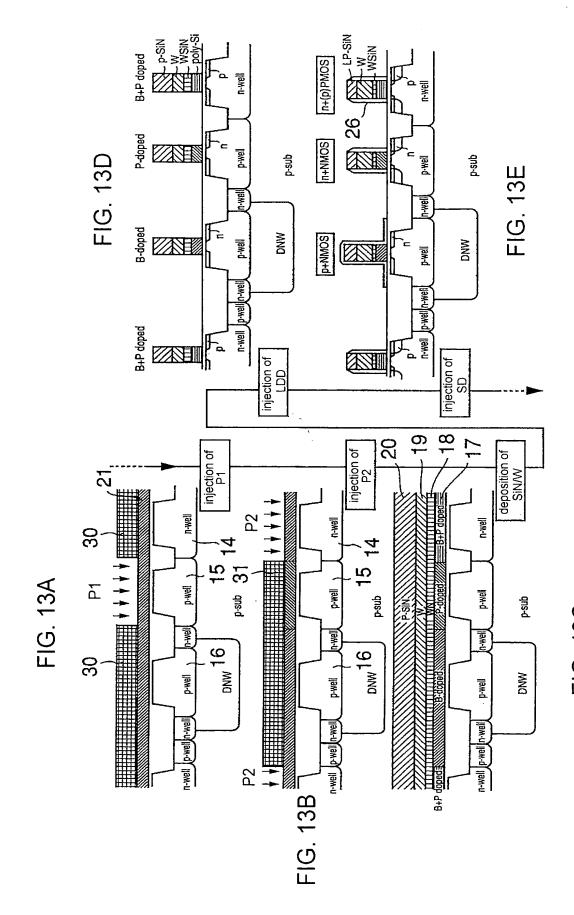


FIG. 13C